

Form PTO-1449 O I P E INFORMATION DISCLOSURE CITATION IN AN APPLICATION JUL 01 2002 <i>(use several sheets if necessary)</i>		Docket Number (Optional) 4368US (99-0959)	Application Number 09/874,631			
		Applicants Moon et al.				
		Filing Date June 5, 2001	Group Art Unit 2815			
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	
<i>SVL</i>	4,807,021	02/1989	Okumura	—	—	
<i>SVL</i>	5,366,794	11/1994	Nakao	—	—	
<i>SVL</i>	5,385,869	01/1995	Liu et al.	—	—	
<i>SVL</i>	5,397,921	03/1995	Karnezos	—	—	
<i>SVL</i>	5,409,865	04/1995	Karnezos	—	—	
<i>SVL</i>	5,504,277	04/1996	Danner	—	—	
<i>SVL</i>	5,663,530	09/1997	Schueller et al.	—	—	
<i>SVL</i>	5,668,405	09/1997	Yamashita	—	—	
<i>SVL</i>	5,674,785	10/1997	Akram et al.	—	—	
<i>SVL</i>	5,697,148	12/1997	Lance, Jr. et al.	—	—	
<i>SVL</i>	5,710,071	01/1998	Beddingfield et al.	—	—	
<i>SVL</i>	5,719,449	02/1998	Strauss	—	—	
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
						YES
						NO
OTHER DOCUMENTS						(Including Author, Title, Date, Pertinent Pages, Etc.)
<i>SVL</i> U. S. Patent Application entitled MICROELECTRONIC DEVICES AND METHODS OF MANUFACTURE, filed August 30, 2001, Serial No. 09/944,465.						
EXAMINER			DATE CONSIDERED			<i>9/2002</i>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						

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U.S. PATENT DOCUMENTS							
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<i>SLC</i>	5,721,151	02/1998	Padmanabhan et al.				
<i>SLC</i>	5,739,585	04/1998	Akram et al.				
<i>SLC</i>	5,747,982	05/1998	Dromgoole et al.				
<i>SLC</i>	5,752,182	05/1998	Nakatsuka et al.				
<i>SLC</i>	5,758,413	06/1998	Chong et al.				
<i>SLC</i>	5,798,285	08/1998	Bentlage et al.				
<i>SLC</i>	5,818,113	10/1998	Iseki et al.				
<i>SLC</i>	5,834,338	11/1998	Takeda et al.				
<i>SLC</i>	5,835,355	11/1998	Dordi				
<i>SLC</i>	5,843,808	12/1998	Karnezos				
<i>SLC</i>	5,844,168	12/1998	Schueller et al.				
<i>SLC</i>	5,886,408	03/1999	Ohki et al.				
FOREIGN PATENT DOCUMENTS							
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						YES	NO
OTHER DOCUMENTS						(Including Author, Title, Date, Pertinent Pages, Etc.)	
EXAMINER <i>Mark</i>				DATE CONSIDERED <i>9/2002</i>			
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Form PTO-1449 INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION <i>(Use several sheets if necessary)</i>		Docket Number (Optional) 4368US (99-0959)		Application Number 09/874,631			
		Applicants Moon et al.					
		Filing Date June 5, 2001		Group Art Unit 2815			
		U.S. PATENT DOCUMENTS					
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS		
	5,973,404	10/1999	Akram et al.	—	—		
	5,984,691	11/1999	Brodsky et al.	—	—		
	5,991,161	11/1999	Samaras et al.	—	—		
	6,008,543	12/1999	Iwabuchi	—	—		
	6,011,694	01/2000	Hirakawa	—	—		
	6,024,584	02/2000	Lemke et al.	—	—		
	6,027,346	02/2000	Sinsheimer et al.	—	—		
	6,050,832	04/2000	Lee et al.	—	—		
	6,057,178	05/2000	Galuschki et al.	—	—		
	6,072,233	06/2000	Corisis et al.	—	—		
	6,075,710	06/2000	Lau	—	—		
	6,079,991	06/2000	Lemke et al.	—	—		
FOREIGN PATENT DOCUMENTS							
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						YES	NO
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EXAMINER <i>Clark</i>			DATE CONSIDERED <i>6/9/2002</i>				
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